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CONFIRMATION NO. 2777

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|--|--|--|------------------------|------------------------------------|----------------------------|
| SERIAL NUMBER 10/747,862 | FILING DATE 12/29/2003 RULE | CLASS 257 | GROUP ART UNIT 2815 | ATTORNEY DOCKET NO. TI-34210 | |
| APPLICANTS | | | | | |
| John C. Ehmke, Garland, TX; Vincent C. Lopes, Lucas, TX; John Paul Harris, Whitewright, TX; | | | | | |
| ** CONTINUING DATA ***** | | | | | |
| ** FOREIGN APPLICATIONS ***** | | | | | |
| IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 04/13/2004 | | | | | |
| Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged | <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance Examiner's Signature | STATE OR COUNTRY TX | SHEETS DRAWING 5 | TOTAL CLAIMS 25 | INDEPENDENT CLAIMS 2 |
| Initials | | | | | |
| ADDRESS 23494 TEXAS INSTRUMENTS INCORPORATED P O BOX 655474, M/S 3999 DALLAS , TX 75265 | | | | | |
| TITLE Method for fabricating a lid for a wafer level packaged optical MEMS device | | | | | |
| FILING FEE RECEIVED 990 | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | <input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ | | | |